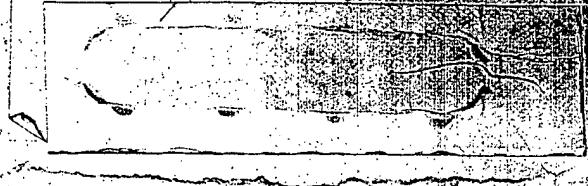


	Subclass
	Class



PATENT NUMBER

U.S. UTILITY Patent Application

9.I.P.E.  PATENT DATE

APPLICATION NO. 09/740146	CONT/PRIOR D	CLASS 156	SUBCLASS 345	ART UNIT 1763	EXAMINER Gupta Hassan	
APPLICANT'S NAME Ajay Kumar Jeffrey Chinn Dragan Podlesnik		BEST AVAILABLE COPY				
Apparatus for performing self cleaning method of forming deep grooves in silicon substrates						
TITLE						PTO-2040 12/99

ISSUING CLASSIFICATION

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Figure 1. *Scanning electron micrograph of the surface of a 100 nm diameter particle.*

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